

## Electronic Patent Application Fee Transmittal

Application Number:	10516457			
Filing Date:	03-Dec-2004			
Title of Invention:	Heating jacket for plasma etching reactor, and etching method using same			
First Named Inventor/Applicant Name:	Michel Puech			
Filer:	David J. Cushing/Kathleen Clark			
Attorney Docket Number:	Q84448			

Filed as Large Entity

### U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 1 month with \$0 paid	1251	1	120	120

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>120</b>